

L Number	Hits	Search Text	DB	Time stamp
2	0	(nano adj needle\$1) same (etch\$8 or litho\$8)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/03/03 12:04
3	18	nanoprobe same (etch\$8 or litho\$8)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/03/03 12:08
4	0	nano-probe same (etch\$8 or litho\$8)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/03/03 12:08
5	0	nano-probe\$1 same (etch\$8 or litho\$8)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/03/03 12:08
6	26	nanoprobe\$1 same (etch\$8 or litho\$8)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/03/03 12:08

L Number	Hits	Search Text	DB	Time stamp
1	1771	(250/492.2).CCLS.	USPAT; US-PGPUB	2004/03/03 10:07
2	1621	(250/492.2).CCLS.	USPAT	2004/03/03 10:16
4	9	(nano adj tube\$1) same lithography	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/03/03 10:38
5	42	(nano adj tube\$1) same etch\$5	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/03/03 10:36
6	1	(nano adj probe\$1) same etch\$5	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/03/03 10:37
7	0	(nano adj probe\$1) same lithography	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/03/03 10:38
8	0	(nano adj probe\$1) same litho\$8	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/03/03 10:39
9	707	nano same etch\$5	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/03/03 10:39
10	0	(nano same etch\$5) and 250/492.2-492.22	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/03/03 10:39